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10/567,729	02/01/2006	Kazutoshi Kojima	OGOSH46USA

## CONFIRMATION NO. 7682

270  
HOWSON AND HOWSON  
SUITE 210  
501 OFFICE CENTER DRIVE  
FT WASHINGTON, PA19034

**Title:** Silicon carbide epitaxial wafer, method for producing such wafer, and semiconductor device formed on such wafer

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